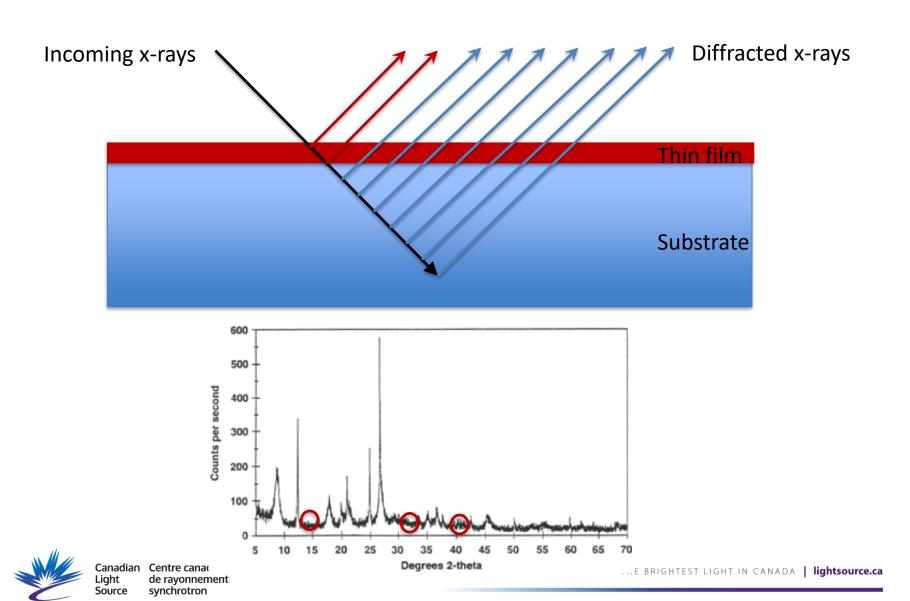


Using x-rays to investigate thin films



TOPICS

1. Motivation

2. Is the film thin?

3. X-ray Attenuation

Techniques:

a) GI-powder XRD

b) GI-single crystal XRD

c) Reflectivity

d) GISAXS

Motivation



Three Most Common Issues Coatings Address:

- 1. Friction
- 2. Heat
- 3. Corrosion

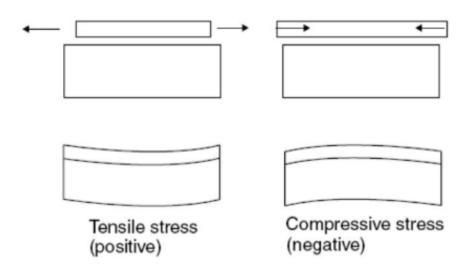


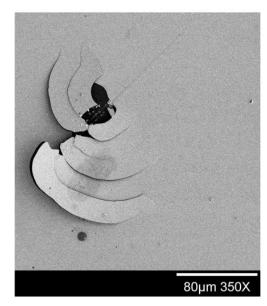


Structure



Performance





Stress fracture patterns in ALD W/Si





What can we measure?

Small angle x-ray reflectivity

GI-SAXS

GI-WAXS -- GI -- PXRD -- GI -- RSM

Reflectivity XRD Pole figures

They yield information about:

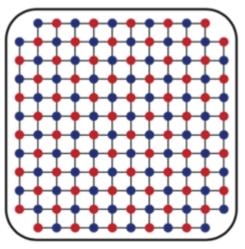
- √ Film thickness, roughness, porosity
- ✓ Structure, stress, texture, defects
- ✓ Composition, interdiffusion, gradients
- ✓ Buried nanostructures, size, shape, ordering



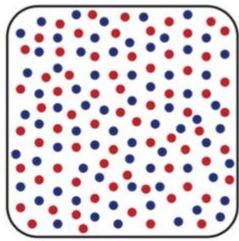


What kind of films can we measure?

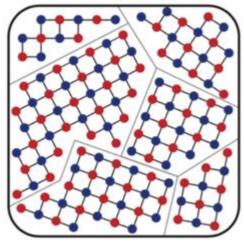
Single-crystal



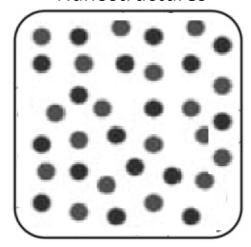
Amorphous



Poly-crystalline

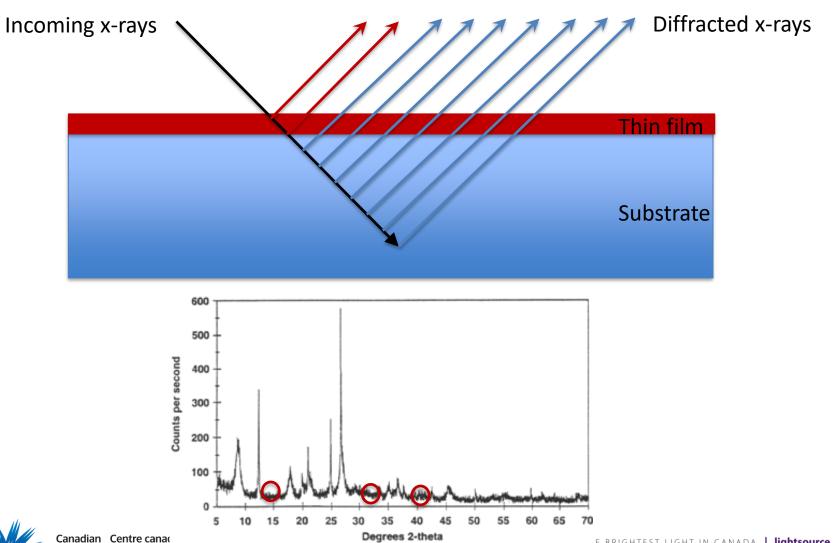


Nanostructures





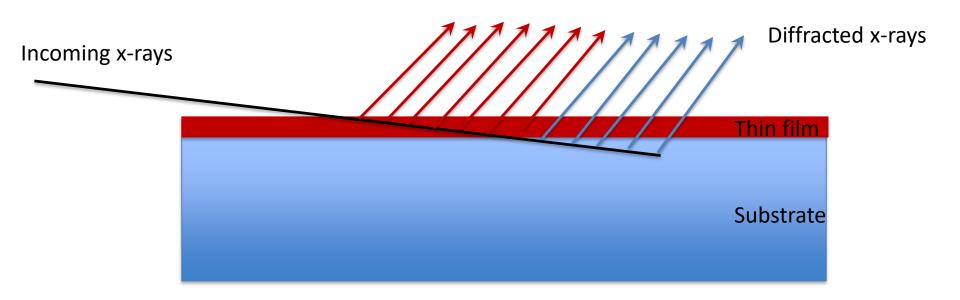
Using X-Rays to investigate thin films





Source

The grazing incidence geometry enhances the film signal relative to the substrate signal





The **attenuation length** ε is the distance over which the x-ray beam intensity has dropped to 1/e of its incident intensity.

Denser materials will have shorter attenuation lengths.

Higher energies will have longer attenuation lengths

The **attenuation coefficient** μ is simply the inverse of the attenuation length

Where to find attenuation lengths of materials:

- CXRO
- XOP/XPOWER
- ...

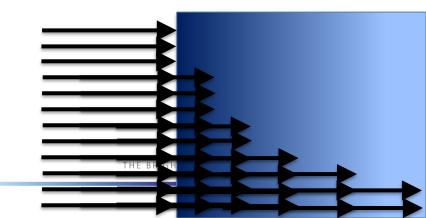


e = 2.718281828459045 1/e = 0.367879441171

$$I = I_o e^{-\frac{d}{\varepsilon}}$$

$$I = I_o e^{-\mu . d}$$

d





X-Ray Database	Ð
Nanomagnetism	0
X-Ray Microscopy	0
EUV Lithography	0
EUV Mask Imaging	0
Reflectometry	0
Zoneplate Lenses	0
Coherent Optics	0
Nanofabrication	0
Optical Coatings	0
Engineering	0
Education	0
Publications	0
Contact	0





The Center for X-Ray Optics is a multi-disciplined research group within Lawrence Berkeley National Laboratory's (LBNL) Materials Sciences Division (MSD). Notice to users.

X-Ray Interactions With Matter

Introduction

Access the atomic scattering factor files.

Look up x-ray properties of the elements.

The index of refraction for a compound material.

The x-ray attenuation length of a solid.

X-ray transmission

- Of a solid.
- Of a gas.

X-ray reflectivity

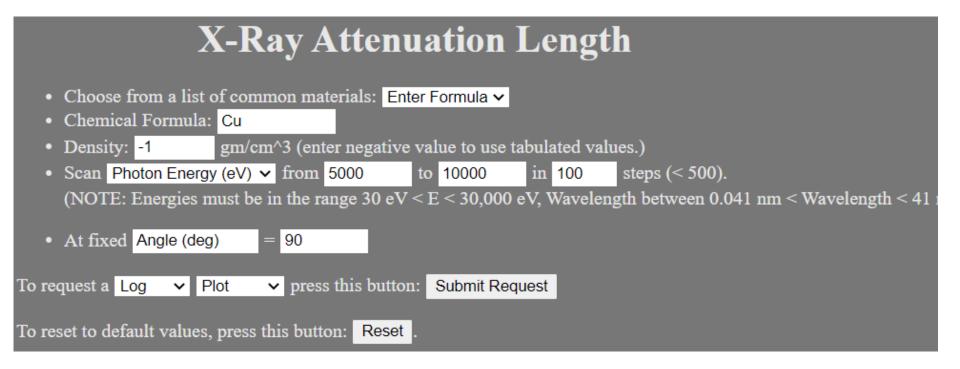
- · Of a thick mirror.
- · Of a single layer.
- · Of a bilayer.
- · Of a multilayer.

The diffraction efficiency of a transmission grating.

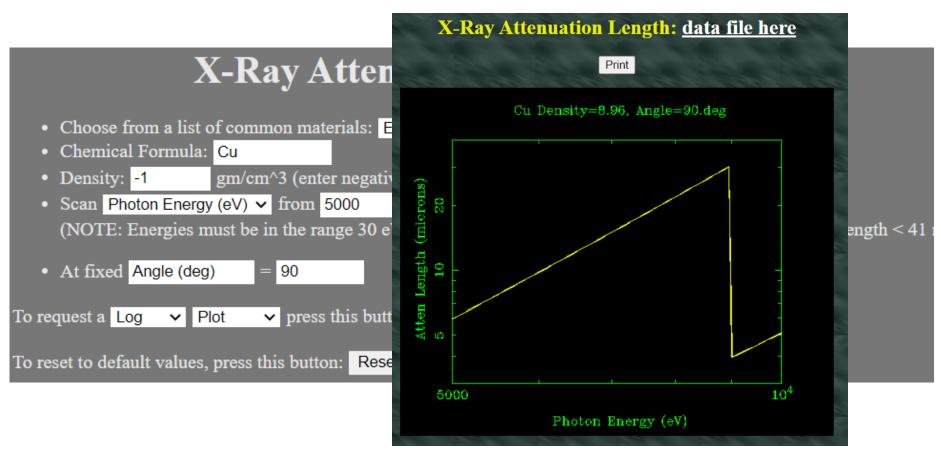
Related calculations:

Synchrotron bend magnet radiation.

Other x-ray web resources. X-ray Data Booklet





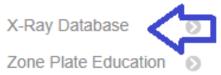




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Element 29: Cu





5664.42

5703.82

5743.49

5783.44

5823.67

5864.17 9.22514

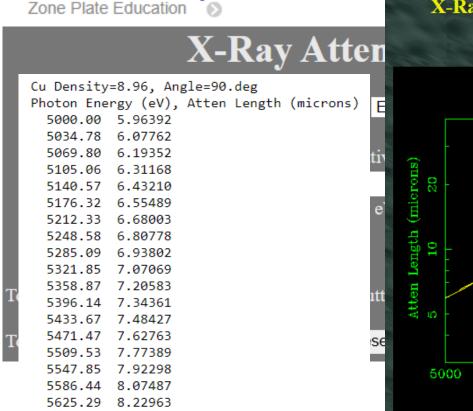
8.38748

8.54873

8.71308

8.88042

9.05096

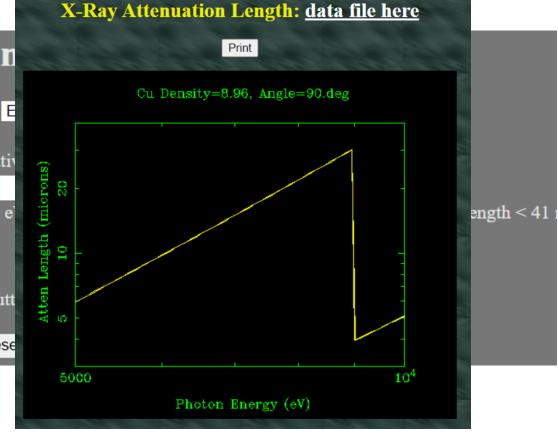


Element 29: Cu

keV

8.9789

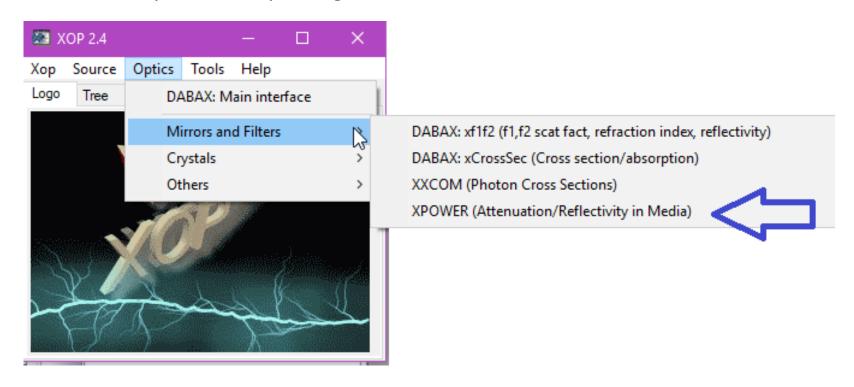
Edge

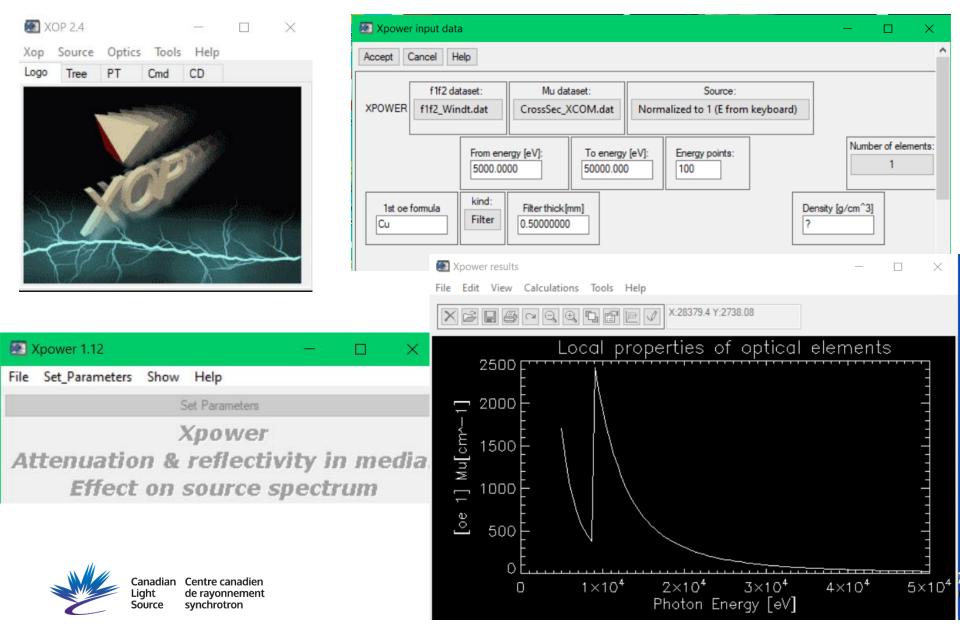


THE BRIGHTEST LIGHT IN CANADA | lightsource.ca

XOP/XPOWER

https://www.aps.anl.gov/Science/Scientific-Software/XOP



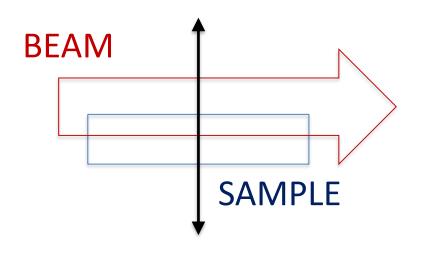


How do we measure?

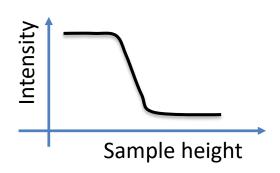


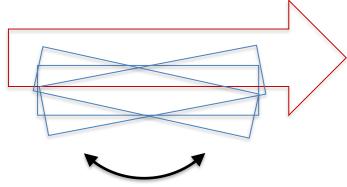


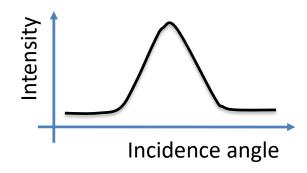
Sample alignment





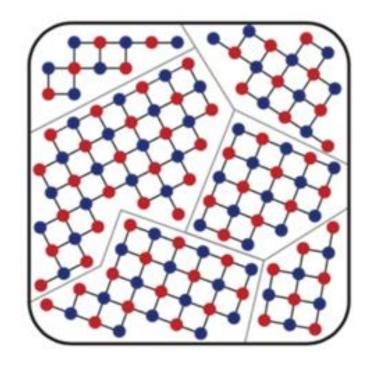






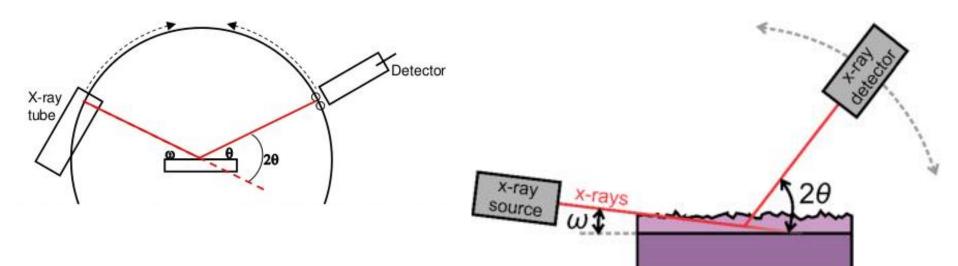
Iterate!

Grazing incidence diffraction applied to polycrystalline films



Regular specular geometry, $\omega = \theta$

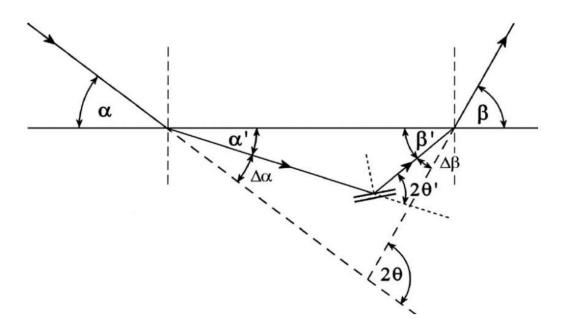
Grazing incidence geometry



https://www.sciencedirect.com/science/article/pii/S0022311517313946



Refraction correction

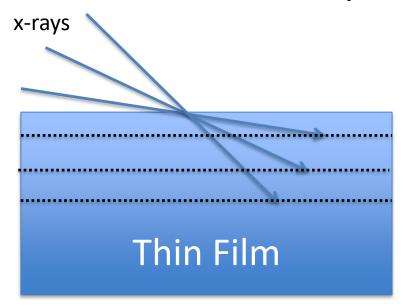


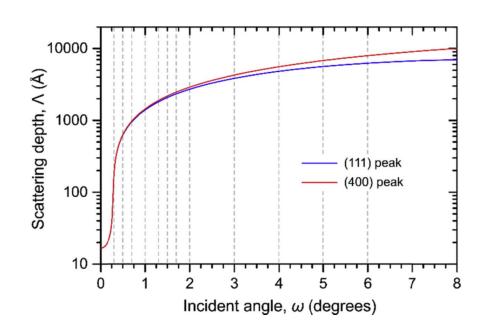
$$\Delta 2\theta = \delta [\cot \alpha + \cot(2\theta - \alpha) + 2 \tan \theta]$$

Powder Diffraction **24**(S1): S11-S15, 2012



Depth sensitivity

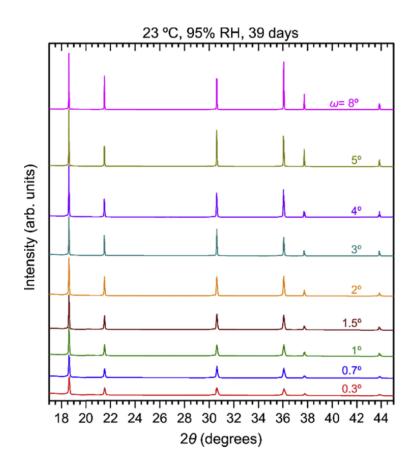


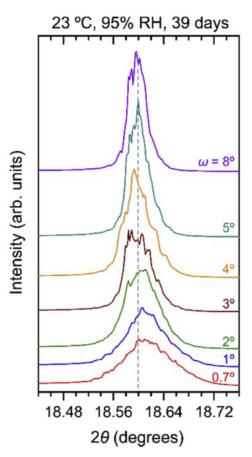


Journal of Nuclear Materials 502: 68-75, 2018.



Uranium Oxide (UO₂) exposed to air



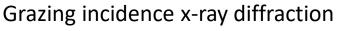


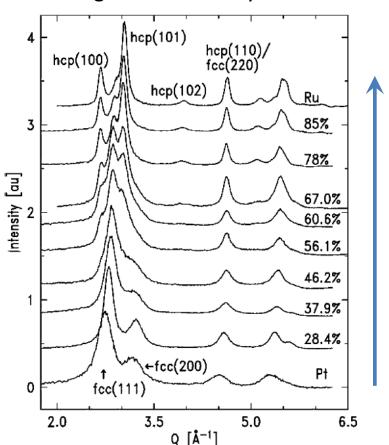
Journal of Nuclear Materials 502: 68-75, 2018.



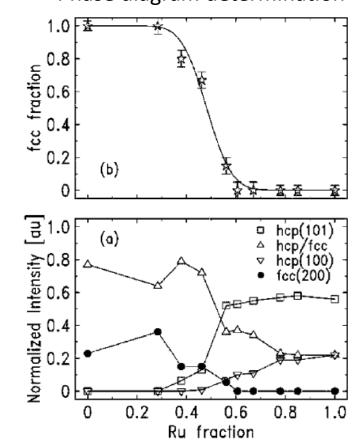
Structure and electrocatalysis of sputtered RuPt thin-film electrodes

130 Å thick





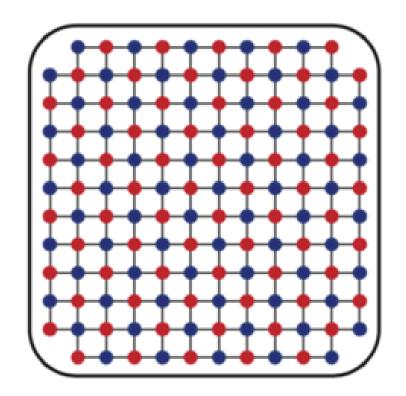
Phase diagram determination



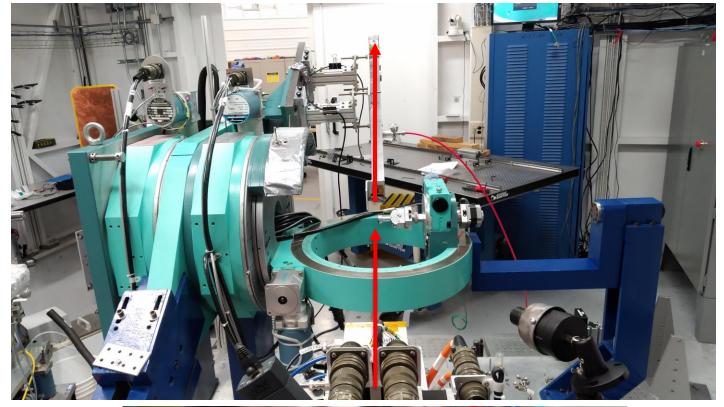


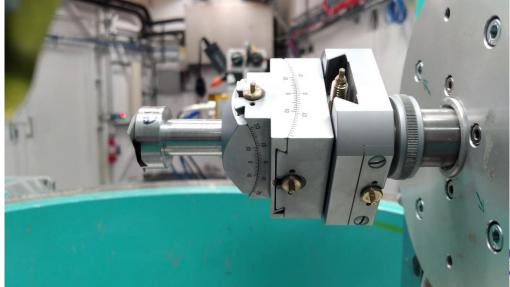
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applied to single crystal films



GID setup



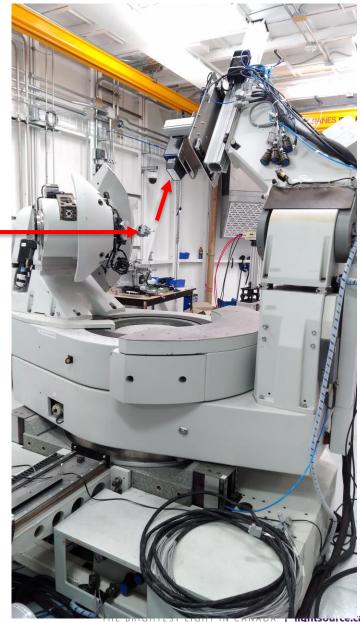




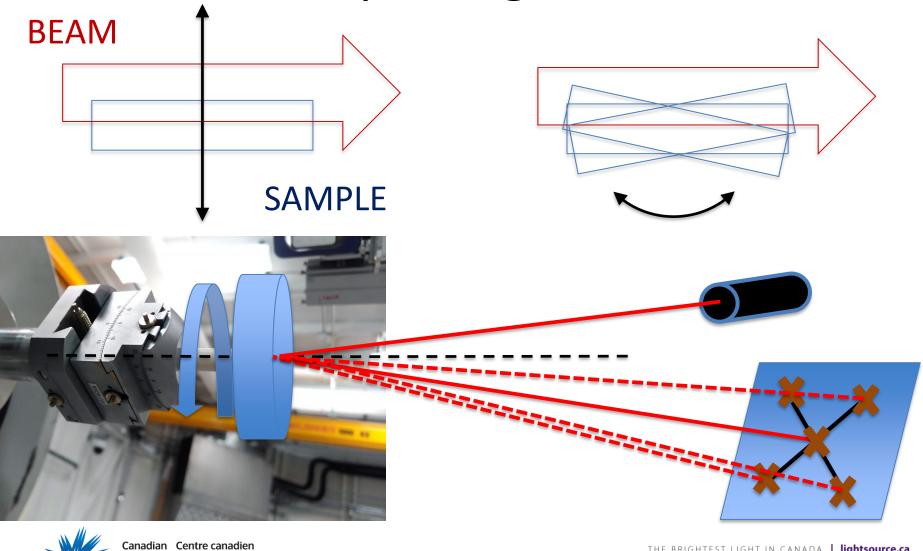
Canadian Light Centre canadien de rayonnement Source synchrotron

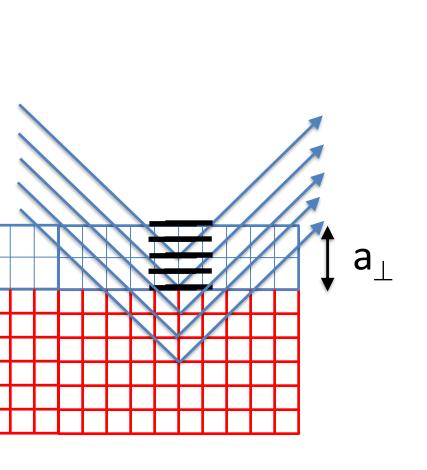
GID setup

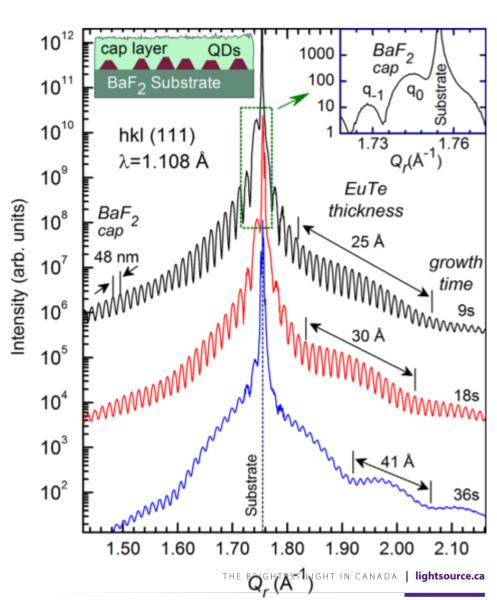




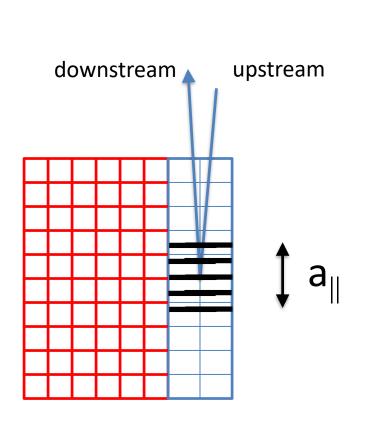
Sample alignment

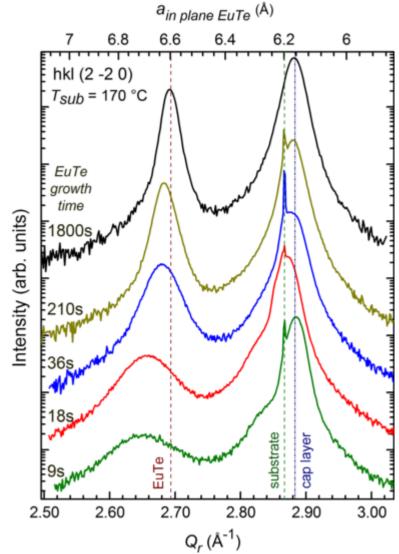






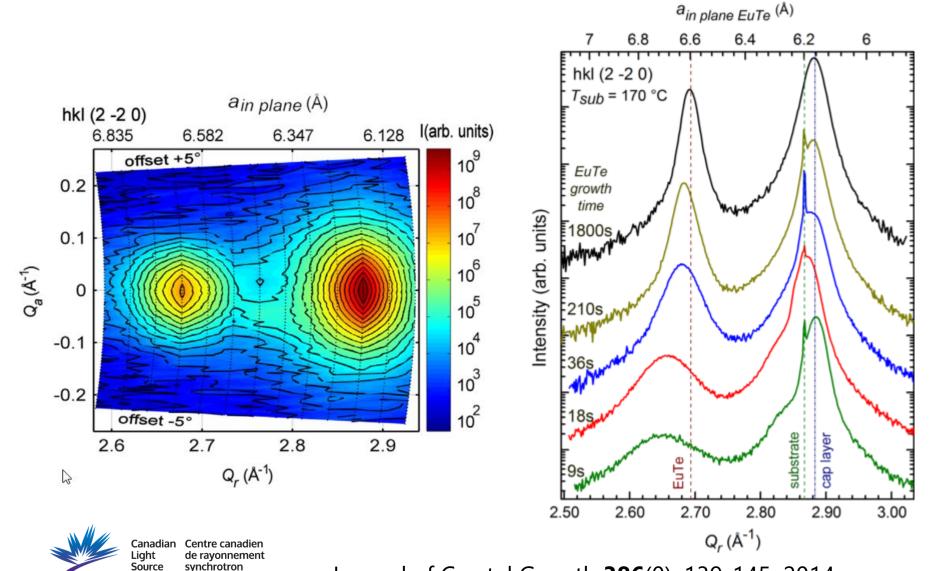








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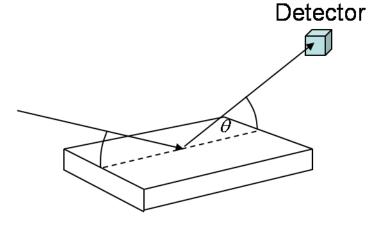
Journal of Crystal Growth **386**(0): 139-145, 2014

Single crystal films
Polycrystalline films
Amorphous films

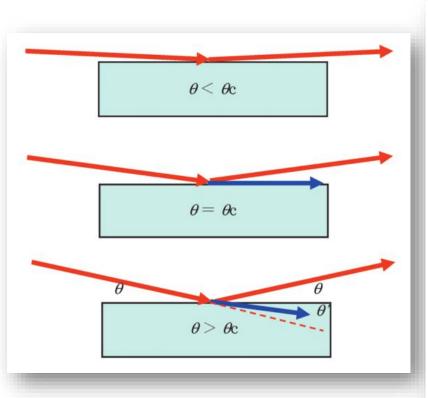


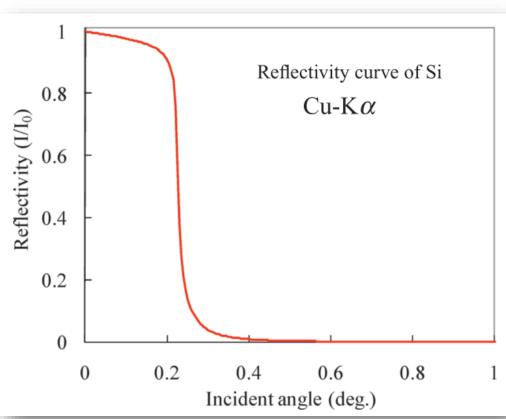
- Reflectivity yields information about the
 - Thicknesses
 - Density / porosity
 - Roughness of the interfaces

- Other names:
 - X-ray specular reflectivity
 - X-ray reflectometry
 - > XRR



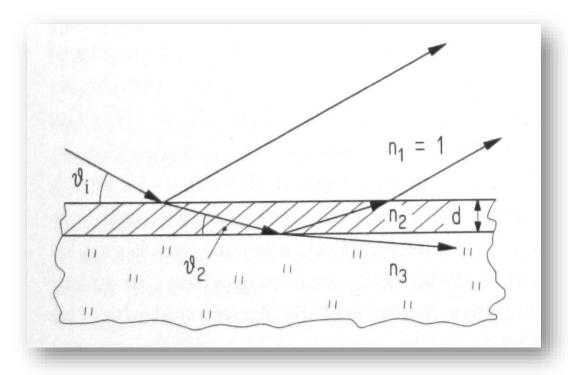
No diffraction!





 $\theta_c \sim \lambda \sqrt{\rho}$





Snell's law

$$n_1 \cos \vartheta_1 = n_2 \cos \vartheta_2$$

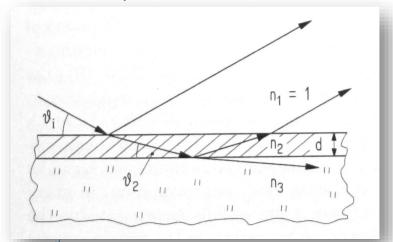
 $n = 1 - \delta + i \beta$

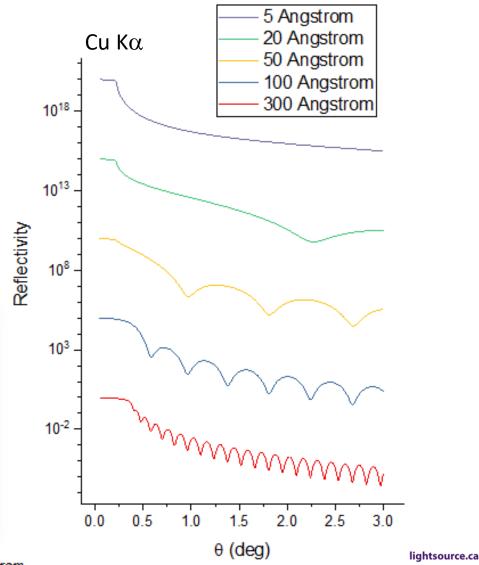


Reflectivity of a chromium film on top of silicon substrate, Cr/Si, for different thicknesses between 5 and 300 Å.

Kiessig fringes

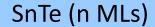
$$d = \frac{\lambda}{2\Delta\theta_{x}}$$







 $\frac{1.54 \cdot Angstrom}{2 \cdot 0.01 \cdot deg} = 0.4 \ \mu m$



EuTe (m MLs)

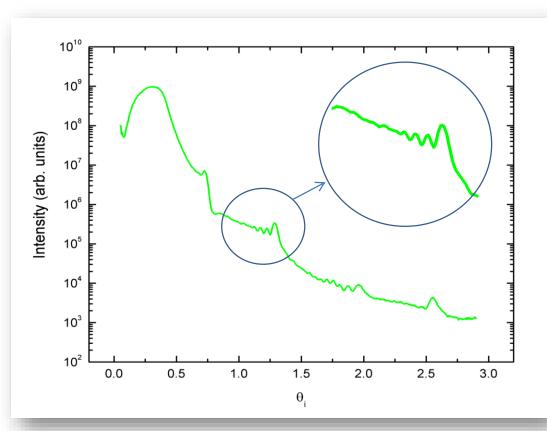
d1

d2

SnTe buffer layer ~3 µm

Substrate(111)BaF

$$d = \frac{\lambda}{2\Lambda \cdot 9}$$



Kiessig fringes spacing:

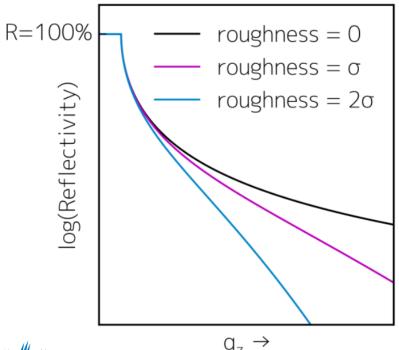
 $0.61 \deg \sim 83 \text{ Å}$ (SL period)

 $0.05 \text{ deg} \sim 994.9 \text{ Å}$ (Stack thickness)

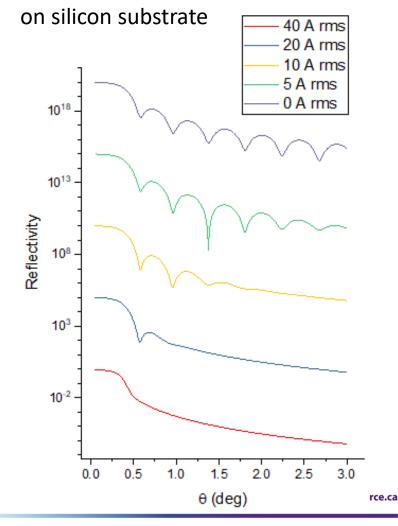


Surface roughness

$$R_{rough} = R \cdot e^{-\frac{q_z^2 \sigma^2}{2}}$$



100 Angstrom chromium layer



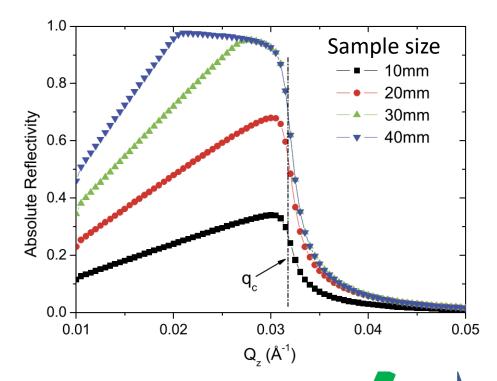


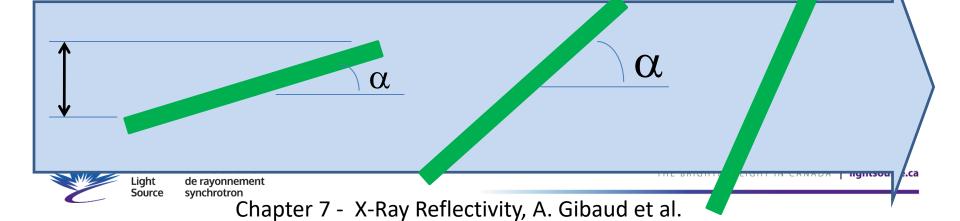
Footprint correction

Beam footprint length:

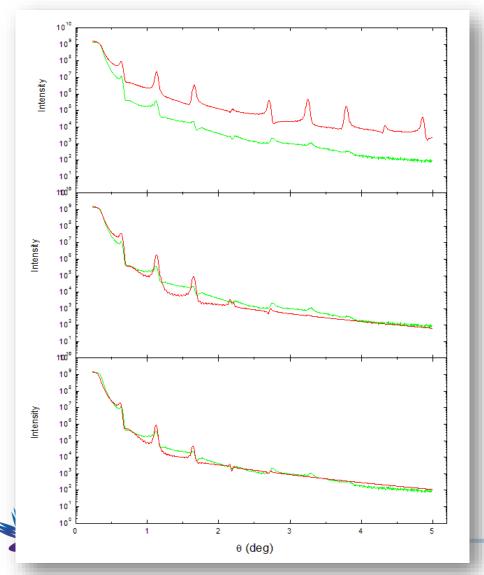
$$F = \frac{t}{\sin(\alpha)}$$

$$R = \frac{I}{I_0}$$





Fits to the measurement



Smooth interfaces Rough interfaces Lower densities (porous sample?) Oxide layer cap I Inghtsource.ca

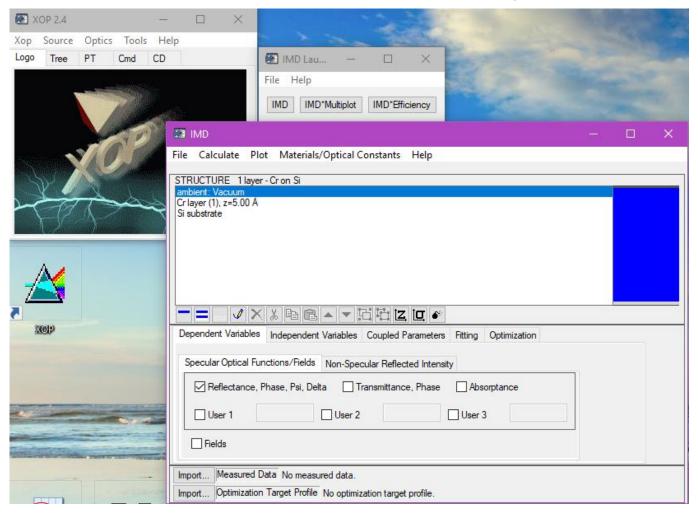
Programs for simulating and fitting reflectivity

- GSAS II!
- Parratt 32
- RFit2000
- WinGixa (Panalytical)
- XOP / IMD

For more x-ray related softwares, consult website: http://gisaxs.com/index.php/Software#Crystallography



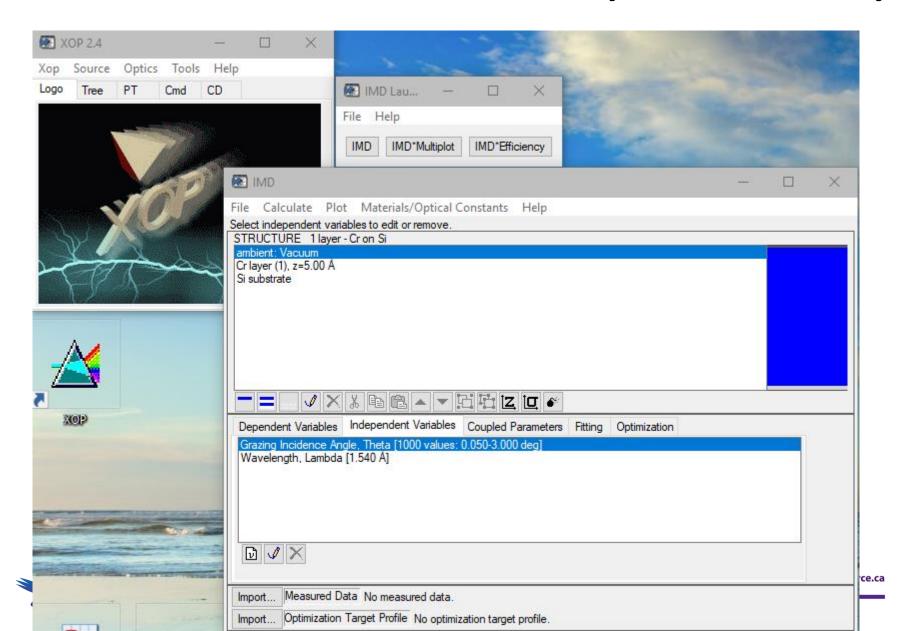
IMD/XOP to simulate x-ray reflectivity



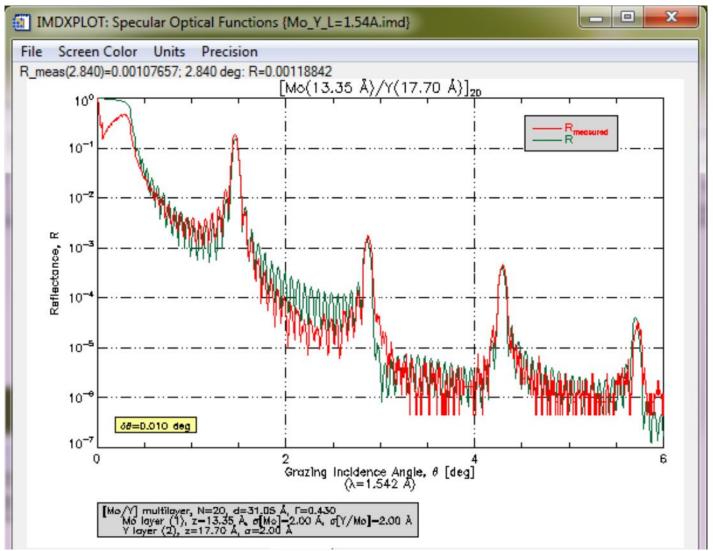
https://www.aps.anl.gov/Science/Scientific-Software/XOP



IMD/XOP to simulate x-ray reflectivity



IMD/XOP to simulate x-ray reflectivity



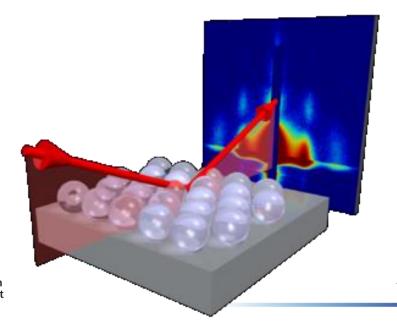


Source

Grazing Incidence

Small Angle X-ray Scattering

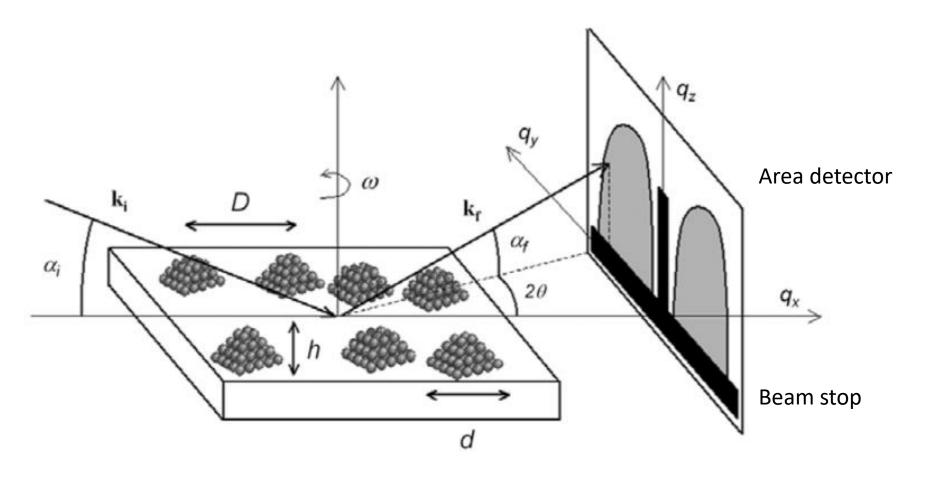
GISAXS





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GISAXS measurements

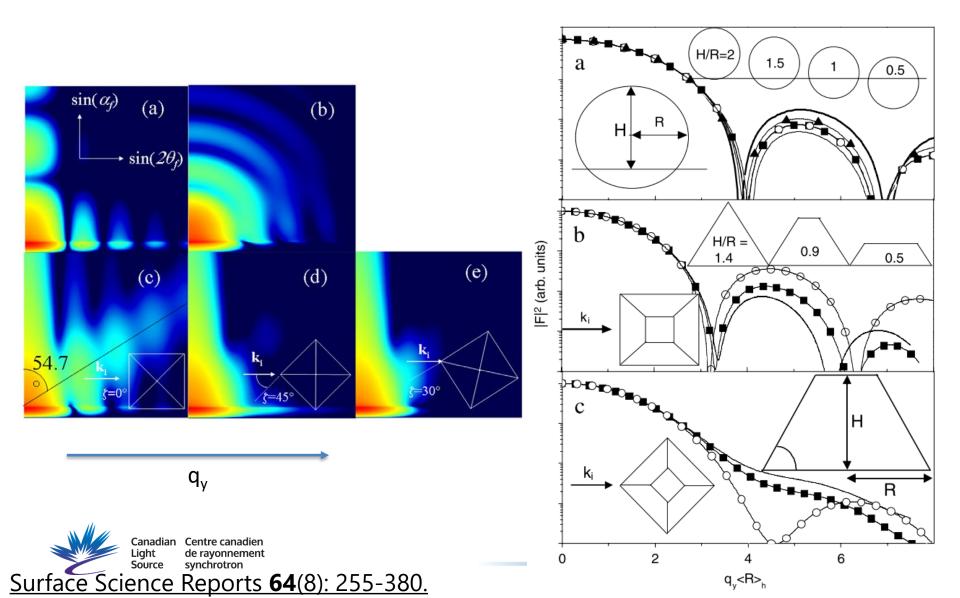


Surface Science Reports 64(8): 255-380, 2009.



GISAXS:

Form factors of particles of different shapes



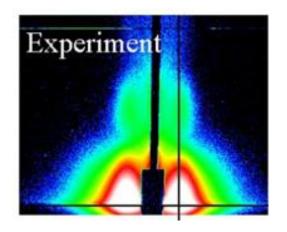
Modelling software

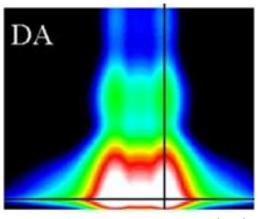
- R. Lazzari, IsGISAXS: A program for grazing-incidence small-angle X-ray scattering analysis of supported islands, J. Appl. Crystallogr. 35 (2002) 406– 421.
- http://www.insp.jussieu.fr/oxydes/IsGISAXS/isgisaxs.htm
- Jiang, Z. (2015). "GIXSGUI: a MATLAB toolbox for grazing-incidence X-ray scattering data visualization and reduction, and indexing of buried three-dimensional periodic nanostructured films." <u>Journal of Applied Crystallography</u> 48(3): 917-926.
- https://www.aps.anl.gov/Science/Scientific-Software/GIXSGUI
- FitGISAXS, BornAgain, HipGISAXS, NANOCELL, SimDiffraction,...



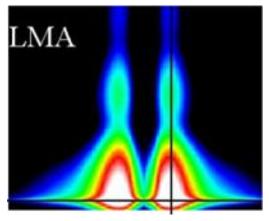
IsGISAXS

Pd islands on MgO(100)

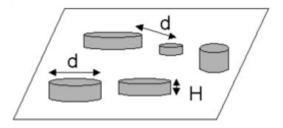




Decoupling Approximation (DA)



Local Monodisperse Approximation (LMA)



PARAMETERS: cylinder D = 20.7 nmd = 10.2 nmH = 6.6 nm $\sigma_R = 1.3$ $\sigma_{H} = 1.1$

- ✓ Shape
- ✓ Average size
- ✓ Size spread
- ✓ Distance among them

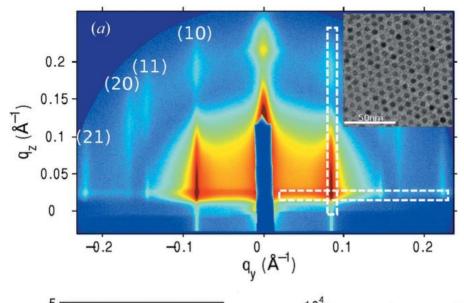


Liaht

Canadian Centre canadien de rayonnement

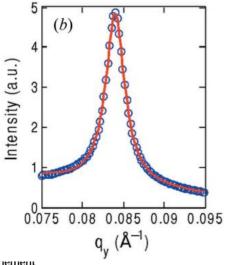
GISAXS

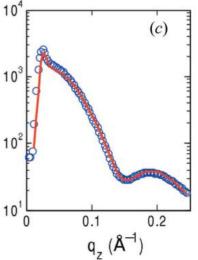
Spherical gold nanoparticles in silicon



Horizontal line profile:

- ✓ Lattice parameter
- ✓ Coherent domain size





Vertical line profile:

- √ Nanoparticle size
- Polydispersity

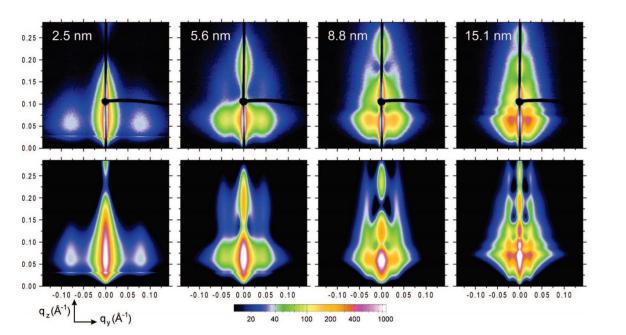


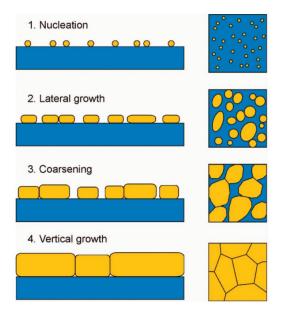
Canadian Light Source

Centre de rayonnement synchrotron EST LIGHT IN CANADA | lightsource.ca

In situ GISAXS

Gold film growth on conducting polymer





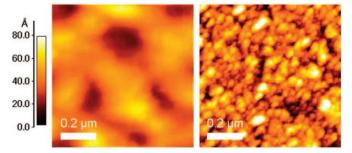
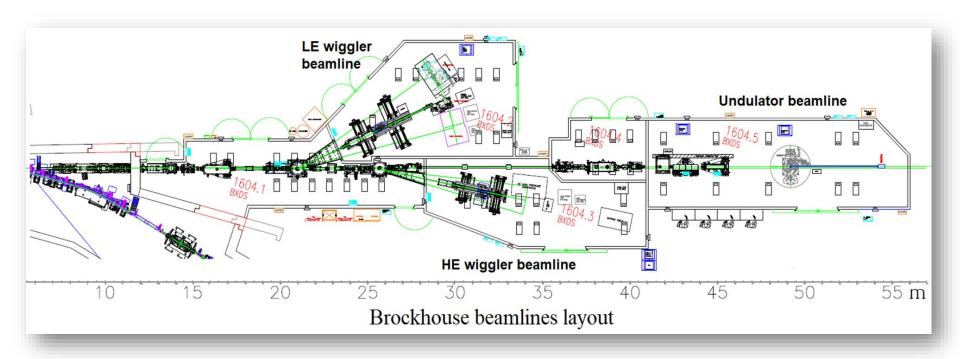


Table 1. Morphological Parameters Extracted from Simulation of the Data by Use of a Model Consisting of Parallelepiped and Spheroid Particle Geometries To Describe the Cluster Shape^a

t	d_0	d	$r_{ m p}$	$\sigma_{ m p}$	h_{p}	$r_{\rm s}$	$\sigma_{\scriptscriptstyle extsf{S}}$	$h_{\rm s}$	D	ω
(min)	(nm)	(nm)	(nm)	(nm)	(nm)	(nm)	(nm)	(nm)	(nm)	(nm)
9	3.9	2.5	4.8	20.0	3.6	4.8	11.0	4.3	11.8	3.8
19	8.2	5.6	9.1	22.5	6.1	9.1	5.3	6.8	19.0	7.2
29	12.5	8.8	13.5	17.6	8.8	13.5	14.9	9.9	27.0	10.2
49	21.1	15.1	20.0	36.0	15.2	20.0	18.0	16.4	40.0	15.2
				ΤH	E BRIG	HTEST	LIGHT	IN CA	NADA	lights



Thin film characterization at the Brockhouse sector



Beamlines energy range

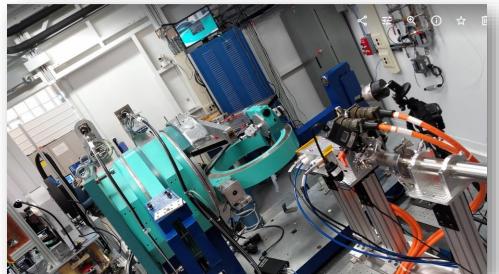
Lower energy wiggler beamline: 7 − 22 keV

Undulator beamline: 5 – 24 keV

Higher Energy wiggler beamline: 20 – 95 keV



Thin film characterization at the Brockhouse sector

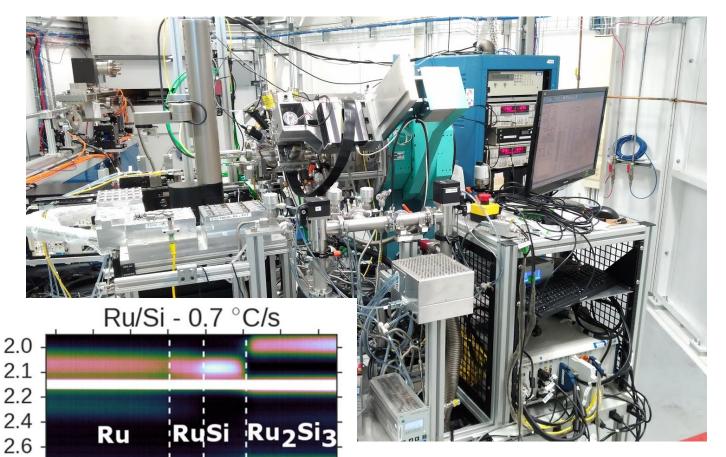






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Thin film characterization at the Brockhouse sector



2.9 3.1

100 200 300 400 500 600 700 800

Temperature [°C]

IBM in-situ station

XRD

RTA up to 1000 °C

H₂ or N₂ ultrahigh purity atmosphere

Resistance probe

Roughness probe

BXDS — Brockhouse X-ray Diffraction and Scattering for materials science

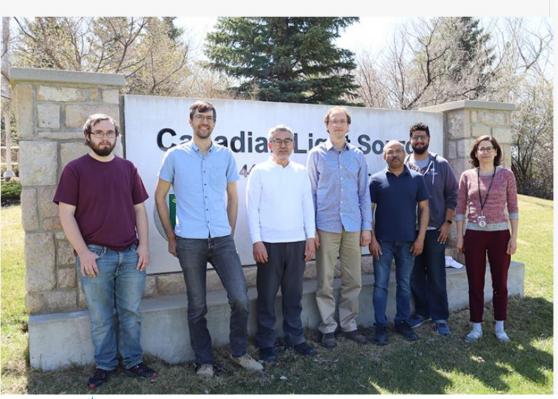
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Welcome to the Brockhouse homepage. We provide a wide range of complementary diffraction and scattering techniques to fully characterize your materials.

High resolution powder diffraction

Pair distribution function (PDF)

High energy diffraction for in-situ studies

Reciprocal space mapping

Small/wide angle X-ray scattering (SAXS/WAXS)

High pressure crystallography

X-ray reflectivity

Grazing incidence diffraction (GID)

Anomalous diffraction and magnetic diffraction



Conclusions

If you have a sample... → measure XRD!

If it is a very thin film... → try one of the techniques with grazing incidence geometry

They can yield information about:

- ✓ Structure / texture / stress
- ✓ Defects
- ✓ Thickness
- ✓ Roughness
- ✓ Composition, interdiffusion, gradients
- ✓ Size, morphology, ordering
- ✓ How does it perform under real working conditions?
 - →Come to a synchrotron and perform in-situ experiments!



Further reading

- Thin Film Analysis by X-Ray Scattering, by Mario Birkholz, 2006
- Surface Science Techniques
 - Chapter 6: Grazing incidence X-Ray diffraction by Osami Sakata and Masashi Nakamura
 - Chapter 7: X-Ray Reflectivity by Gibaud, Chebil and Beuvier
- Renaud, G., et al. (2009). "Probing surface and interface morphology with Grazing Incidence Small Angle X-Ray Scattering." <u>Surface Science Reports</u> 64(8): 255-380



Acknowledgments





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